

ABSTRACT

An apparatus for forming the thin film on the organic light-emitting diode component includes an evaporation resource mechanism, a mixing chamber mechanism, a hollow revolving spindle mechanism, and a vacuum mechanism. The mixing chamber mechanism is coupled to the evaporation resource mechanism. The vacuum mechanism is coupled to the mixing chamber mechanism and is used for generating vacuum in the mixing chamber mechanism. The hollow revolving spindle mechanism has a hollow revolving spindle whose of one end is coupled to the mixing chamber mechanism, a revolving arm coupled to the other end of the hollow revolving spindle and having a surface and a plurality of spraying holes disposed on the surface, and a transmission mean having a driving resource and a transmitting body disposed around the hollow revolving spindle, such that the driving source drives the transmitting body and further the transmitting body drives the hollow revolving spindle.